



PTO (Substitute for form 1449A/PTO) INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary) Sheet 1 of 1	ATTY. DOCKET NO. A9 DIV 12 Client/Matter No. 80168.0340.012	APPLICATION NO. 10/679,611
	FIRST NAMED INVENTOR: Tapesch Yadav	
	FILING DATE October 6, 2003	ART UNIT Not yet accorded

U.S. PATENT DOCUMENTS

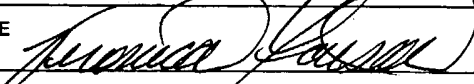
Examiner Initials	Cite No.	Document No. No. - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Doc	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
uff	1	6,413,638		Mager et al.	
	2	6,467,897		Wu et al.	
	3	6,432,526		Arney et al.	
	4	6,110,266		Gonzales-Blanco et al.	
	5	6,057,637		Zettl et al.	
	6	5,764,004		Rabinowitz	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Doc entry code - No. - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Doc	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	TRANSLATION	
						YES	NO

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s) publisher, city and/or country where published
uff	7	DUAN, et al., "High-performance thin-film transistors using semiconductor nanowires and nanoribbons," J. Nature, Vol. 425, 9/18/2003, pp. 274-178.

EXAMINER SIGNATURE 	DATE CONSIDERED 9-29-04
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